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Fax Number: 202-282-5100

FROM: Elizabeth Anderson

DATE: August 26, 2005

APPLN. No.: 10/733,729

OUR REF.: 4717-9200

Please Deliver as Soon as Possible To:

RECIPIENT	COMPANY	FAX NO.	PHONE NO.
Examiner David Nhu	U.S. Patent and Trademark Office	571-273-1792	571-272-1792

Total number of pages including this page: 3

COMMENTS

In re Application of Walter Schwarzenbach et al.
Application No.: 10/733,729
Filed: December 12, 2003
Title: Method of Making Cavities in a Semiconductor

In accordance with our telephone conversation of this afternoon, attached is a courtesy copy of the sheet of replacement drawings including Figs. 3A, 3B, 3C and 5, which will be hand-filed with the USPTO today.

Elizabeth Anderson
Senior Paralegal

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DC:431934.1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: W. SCHWARZENBACH et al. Confirmation No.: 9739
Application No.: 10/733,729 Group Art Unit: 2818
Filing Date: December 12, 2003 Examiner: David Nhu
For: METHOD OF MAKING CAVITIES IN A Attorney Docket No.: 4717-9200
SEMICONDUCTOR

SUBMISSION OF FORMAL DRAWINGS

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P.O. Box 1450
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Sir:


In response to the Notice of Allowability mailed August 11, 2005, submitted herewith is a copy of one (1) sheet of replacement formal drawings including Figs. 3A, 3B, 3C and 5. Applicants respectfully request that the attached sheet of replacement drawings be substituted for the annotated drawings filed on July 27, 2005 and approved by the Examiner on August 11, 2005.

No fee is believed to be due for this submission. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

8/26/05

Date


Jeffrey A. Wolfson (Reg. No. 42,234)

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202-282-5770

Application No.: 10/733,729; Filed: December 12, 2003
Conf. No.: 9739; Atty. Dkt. No.: 4717-9200
Replacement Sheet

2/3

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approved
8/26/05*

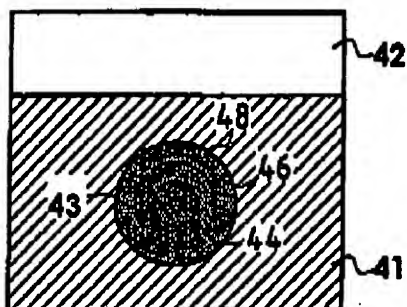


FIG. 3A

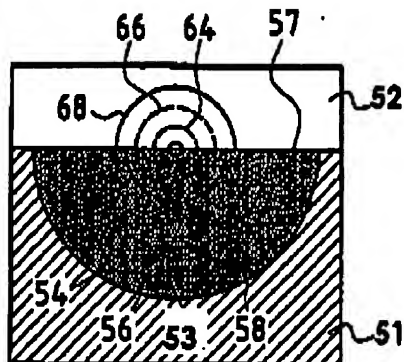


FIG. 3B

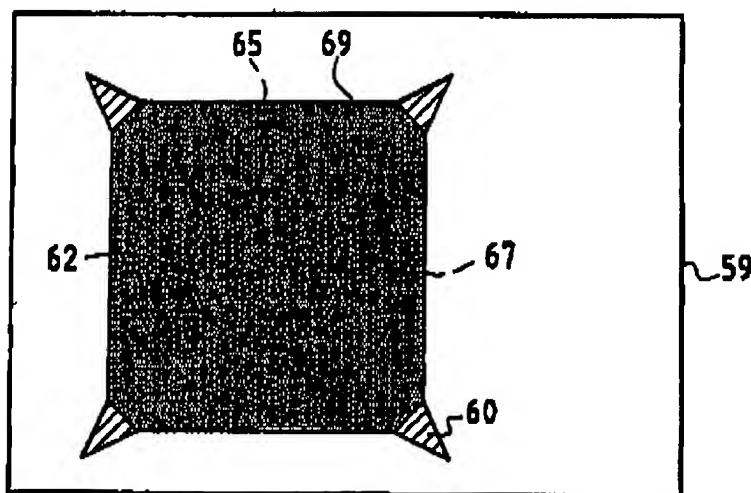


FIG. 3C

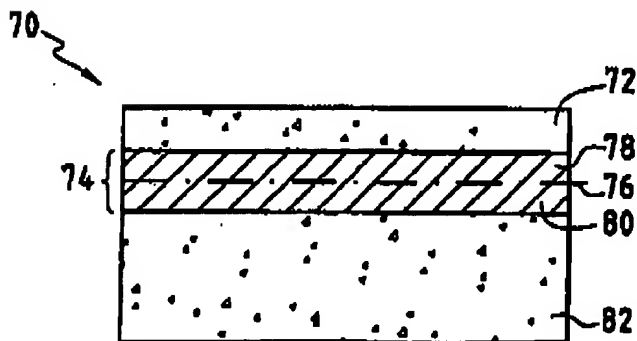


FIG. 5